



PATENT Attorney Docket No. 02887.0259

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Junji SUGAMOTO et al.) Group Art Unit: 2891
Application No.: 10/706,090) Examiner: Smith, Bradley
Filed: November 13, 2003))
For: SEMICONDUCTOR WAFER TREATMENT METHOD, SEMICONDUCTOR WAFER INSPECTION METHOD, SEMICONDUCTOR DEVICE DEVELOPMENT METHOD AND SEMICONDUCTOR WAFER TREATMENT APPARATUS) Confirmation No.: 7292))))))

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed August 2, 2006, the period for response to which extends through November 2, 2006, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks/Arguments follow the amendment section of this paper.